

PLASMA PROCESSES AND POLYMERS

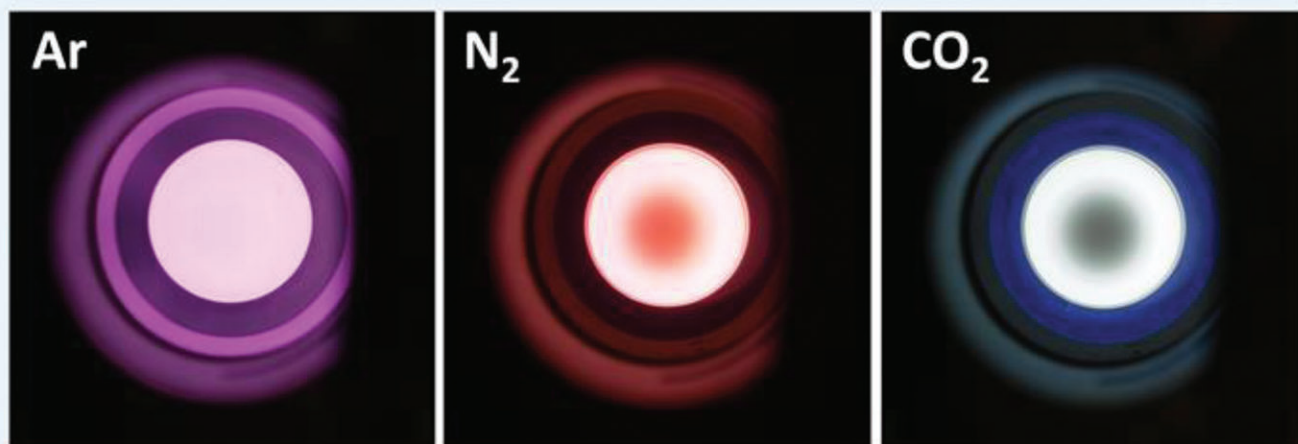
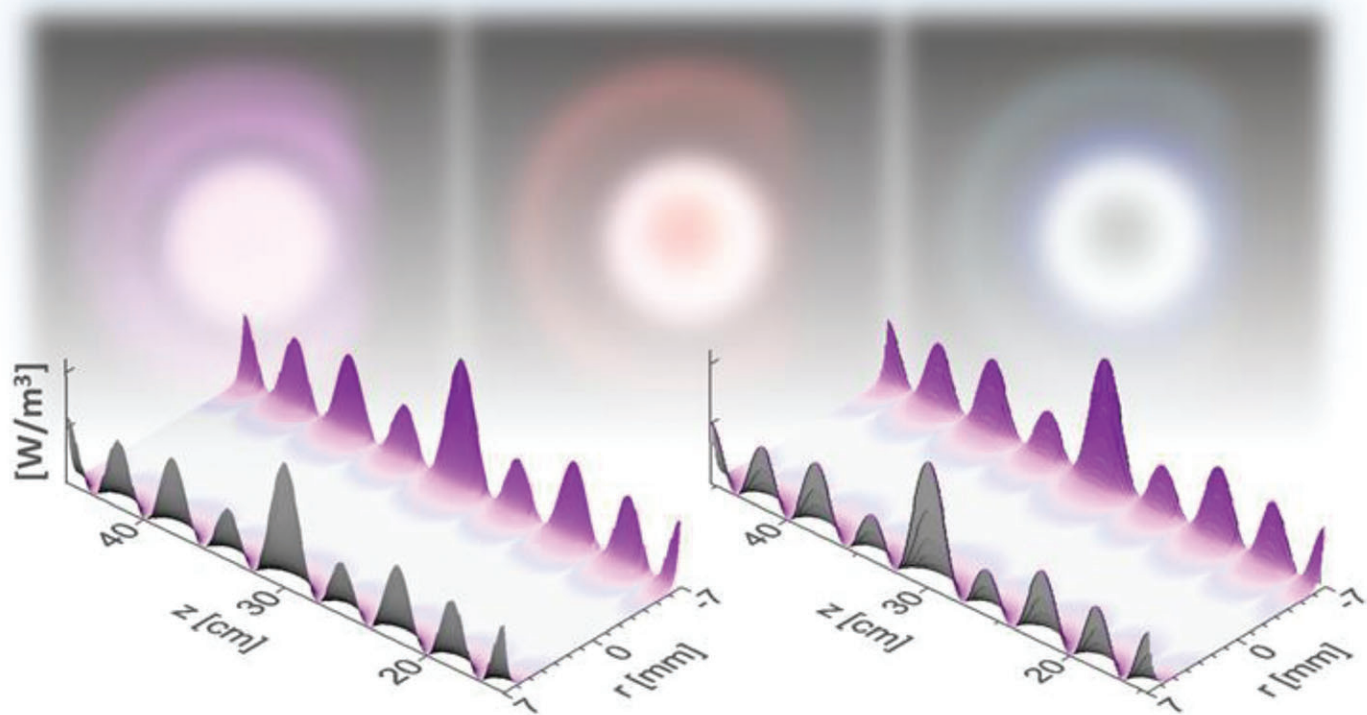


Photo by N. Britun



Quasi-neutral model

Plasma bulk – sheath model

Special Issue:
Numerical Modelling of Low-Temperature Plasmas for Various Applications

Guest Editors:
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